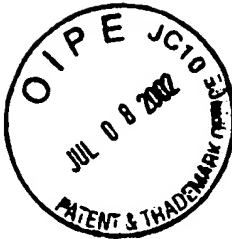


I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS  
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Judy Paschillo 7/1/02  
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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of :

July 1, 2002

BASANTH JAGANNATHAN, ET AL. :

Group Art No.: 2823

Serial No. 09/843,783 :

Examiner: William D. Coleman

Filed: April 30, 2001 :

IBM Corporation  
Bldg. 300, Zip 482  
2070 Route 52  
Hopewell Junction, New York 12533

Title: METHOD TO INCREASE  
CARBON AND BORON DOPING  
CONCENTRATIONS IN SI AND SIGE  
FILMS :

**LETTER TO OFFICIAL DRAFTSMAN**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

Kindly amend Fig. 1 as shown in RED on the attached, per the Examiner's objection  
#2 of the Office Action dated 05/06/2002.

Respectfully submitted,  
BASANTH JAGANNATHAN, ET AL.

By:

Joseph P. Abate 7-1-02  
Joseph P. Abate, Attorney  
Registration No. 30,238  
Tel. (845) 894-4633

JPA/lbg